

**Search Notes**

Application/Control No.

10/532,424

Examiner

Steven D. Maki

Applicant(s)/Patent under  
Reexamination

FUJII ET AL.

Art Unit

1733

**SEARCHED**

Class	Subclass	Date	Examiner
152	154.2		
	209.17		
156	110.1		
73	146		
29	402.03		
	426.1		
updated	above	6/24/2007	<i>SM</i>

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
none	6/24/2007	<i>SM</i>